

ABSTRACT

~~An~~ A pirani absolute pressure sensor for sensing absolute pressure in a load lock in a
range from 100 to 10^{-4} torr and a differential pressure sensor for sensing a pressure difference
between ambient atmospheric pressure and pressure in ~~[[a]]~~ the load lock chamber are
combined together ~~on~~ in a module with a manifold~~[[,]]~~ and ~~with~~ common circuit components
to provide a pressure transducer apparatus that is capable of producing not only analog
output for absolute pressure measurements, but also control signals ~~over a wide pressure~~
~~range~~ at settable absolute and differential pressure values for opening interior and exterior
doors of a load lock used to shuttle wafers and other devices into and out of a vacuum
processing chamber. The transducer can also produce signals to control transition from slow
to fast vacuum ~~pump-down~~ pumping of ~~[[a]]~~ the load lock chamber ~~pressure~~ at a
~~predetermined~~ a settable threshold pressure set point.